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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Case No. 207.008-US)

In the Application of: **Lutz et al.**

Serial No: **10/627,237**

Filed: **July 25, 2003**

Title: **Anchors for Microelectromechanical Systems  
Having an SOI Substrate, and Method for  
Fabricating Same**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

) Group  
) Art Unit: **2812**  
)  
) Before  
) Examiner:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 10, 2004

Date  
Michiko Sates  
(person signing this certificate)

Neil A. Steinberg  
Signature

**FIFTH INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

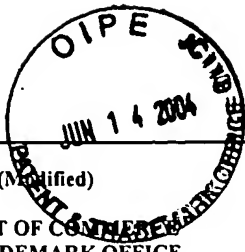
Submitted herewith is one (1) sheet of a modified Form PTO-1449. A copy of each document cited on the attached Form PTO-1449 is also submitted.

It is respectfully requested that the Examiner make his/her consideration of these documents formally of record with the initial Office Action.

Respectfully submitted,

Date: June 10, 2004

Neil A. Steinberg  
Reg. No. 34,735  
650-968-8079



PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 207.008-US	SERIAL NUMBER 10/627,237
	APPLICANT(S) Lutz et al.	
	FILING DATE July 25, 2003	GROUP ART UNIT 2812

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	4,849,071	7/1989	Evans et al.			
	4,945,769	8/1990	Sidner et al.			
	5,445,991	8/1995	Lee			
	5,470,797	11/1995	Mastrangelo			
	5,616,514	4/1997	Muchow et al.			
	6,521,508	2/2003	Cheong et al.			

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	DATE CONSIDERED
EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.	